

Due: Monday, March 10, 2003

1. An abrupt Si p-n junction is formed by alloying a uniformly doped n-type silicon bar where $N_d = 8 \times 10^{16}/\text{cm}^3$ in the beginning. During the alloying process, a uniform counter doping of acceptors of $N_a = 1.4 \times 10^{17}/\text{cm}^3$ is introduced in the region for $x < 0$. Basically, $x < 0$ is the p-side and $x > 0$ is the n-side.
 - (a) Calculate the Fermi level positions at 300 K in the p and n regions.
 - (b) Draw an equilibrium band diagram for the junction and determine the contact potential V_o from the diagram.
 - (c) Compare the results of part (b) with V_o as calculated from Eq. (5-8).
 - (d) Using Eq. (5-8), calculate and plot V_o versus temperature ranging from 250 K to 500 K.
2. Refer to problem 1, the silicon bar has a cross section with diameter 20 μm . Assume that the depletion approximation holds. (a) Calculate W , X_{no} and X_{po} at 300 K. (b) Determine the total positive ion charge in the depletion region. (c) Sketch to scale the charge density $\rho(x)$, electrical field $\mathbf{E}(x)$, and electrostatic potential $V(x)$ in the depletion region. Assume that the electrostatic potential is zero at $x = 0$. (d) Draw the energy band diagram for the device.
3. Refer to problem 1 again. In reality, the alloying process will introduce a much higher concentration of acceptor. Assume that the uniform counter doping is $N_a = 3 \times 10^{19}/\text{cm}^3$ instead. Determine and plot the contact potential V_o and depletion widths W , X_{no} and X_{po} versus temperature ranging from 250 K to 500 K.